



Jin-Goo Park
Professor Hanyang University

Jin-Goo Park received B.S degree in metallurgy and materials engineering from Hanyang University, Korea in 1984 and the M.S. and Ph.D. in materials science and engineering from University of Arizona in 1988 and 1993, respectively. From 1992 to 1994, he was with Texas Instruments, Dallas, TX, where he was responsible for microcontamination control in semiconductor wet processing and DMD development. In 1994, he joined Hanyang University at Ansan, where he is now a professor in the Department of Materials Engineering as well as Directors of Micro Biochip Center and Nano-bio Electronic Materials and Processing Lab. (NEMPL, www.nempl.net). His research interests include wafer cleanings and chemical mechanical polishing as well as nano-bio MEMS. He has authored more than 500 technical publications/presentations in the area of wafer cleanings, CMP and nano-bio MEMS. He is now president of Korea CMPUGM (www.cmpugm.com) and a founder and president of International Conference on Planarization/CMP Technology (ICPT) which is the largest CMP conference in the world. He is also a founder of Korea Surface Cleaning Users Group Meeting (www.scugm.com). He is now vice dean of Graduate School of Hanyang University. He may be reached at 82-31-400-5226 or by email jgpark@hanyang.ac.kr. (as of March 1, 2013)